

WEST Search History

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DATE: Thursday, March 24, 2005

Hide?	Set Name	Query	Hit Count
		<i>DB=DWPI; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L16	(((piezoelectric resonator or film bulk acoustic or fbar or sbar or thin film resonator or tfr or bulk acoustic wave resonator or bulk acoustic resonator or baw))) and ladder and temperature	2
<input type="checkbox"/>	L15	L14 and temperature	6
<input type="checkbox"/>	L14	(((piezoelectric resonator or film bulk acoustic or fbar or sbar or thin film resonator or tfr or bulk acoustic wave resonator or bulk acoustic resonator or baw))) and (series or serial) and (shunt or parallel)	78
		<i>DB=JPAB; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L13	L11 and (series or serial) and (shunt or parallel)	0
<input type="checkbox"/>	L12	L11 and ladder	1
<input type="checkbox"/>	L11	(((piezoelectric resonator or film bulk acoustic or fbar or sbar or thin film resonator or tfr or bulk acoustic wave resonator or bulk acoustic resonator or baw))) and temperature	97
		<i>DB=EPAB; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L10	L9 and temperature	17
<input type="checkbox"/>	L9	(((piezoelectric resonator or film bulk acoustic or fbar or sbar or thin film resonator or tfr or bulk acoustic wave resonator or bulk acoustic resonator or baw)))	354
		<i>DB=USPT; PLUR=YES; OP=ADJ</i>	
<input type="checkbox"/>	L8	L6 and (temperature near2 (compensat\$ or control or coefficient)) and ladder	31
<input type="checkbox"/>	L7	L6 and (sio2 or sio or silicon oxide or silicon dioxide) and ladder	40
<input type="checkbox"/>	L6	piezoelectric resonator or film bulk acoustic or fbar or sbar or thin film resonator or tfr or bulk acoustic wave resonator or bulk acoustic resonator or baw	2184
<input type="checkbox"/>	L5	(((piezoelectric resonator or film bulk acoustic or fbar or sbar or thin film resonator or tfr or bulk acoustic wave resonator or bulk acoustic resonator or baw))) and temperature and (temperature coefficient or temperature compensat\$) and temperature and ladder)	26
<input type="checkbox"/>	L4	(((piezoelectric resonator or film bulk acoustic or fbar or sbar or thin film resonator or tfr or bulk acoustic wave resonator or bulk acoustic resonator or baw))) and temperature and (temperature coefficient or temperature compensat\$) and (sio or sio2 or silicon oxide or silicon dioxide)))	29
<input type="checkbox"/>	L3	(((piezoelectric resonator or film bulk acoustic or fbar or sbar or thin film resonator or tfr or bulk acoustic wave resonator or bulk acoustic resonator or baw))) and temperature and (temperature coefficient or temperature compensat\$)))	179
<input type="checkbox"/>	L2	(((piezoelectric resonator or film bulk acoustic or fbar or sbar or thin film resonator or tfr or bulk acoustic wave resonator or bulk acoustic resonator or baw))) and temperature))	1245
		(((piezoelectric resonator or film bulk acoustic or fbar or sbar or thin film	